

#13/EXT. ①  
3/26/03  
C.P.

Atty Docket No.: 0630.0021C

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

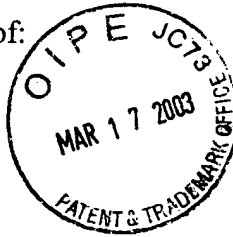
In re the PATENT application of:

Berry et al

Serial No.: 09/505,695

Filed: February 17, 2000

For: Method of Photoresist Ash Residue Removal



Examiner: Le, Thao X.

Group Art Unit: 2814

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TECHNOLOGY CENTER 2800

PETITION FOR EXTENSION OF TIME

Commissioner for Patents  
Washington, D.C. 20231

Sir:

Pursuant to 37 C.F.R. § 1.136(a), Applicant hereby petitions for an extension of time of one month, extending the time period for submitting an Appeal Brief from February 18, 2003 to March 18, 2003. Applicant further petitions that any and all additional extensions of the term necessary to render timely the filing of the accompanying response be granted.

Attached is a Check No. 6675 in the amount of \$110.00 in payment of the fee for a one month extension of time. The commissioner is hereby authorized to charge any additional fees or credit any overpayment to Deposit Account No. 05-0460.

03/18/2003 HDAHTE1 00000037 09505695

02 FC:1251

110.00 OP

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Hand Delivered: March 17, 2003

Respectfully submitted,

Martin Abramson

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